

Notice of References Cited	Application/Control No. 10/764,605		Applicant(s)/Patent Under Reexamination HARTZELL ET AL.	
	Examiner DAVID S. KIM		Art Unit 2613	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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